



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Masashi Fujimoto

Serial No.: 09/981,912

Group Art Unit: Not Yet Assigned

Filing Date: October 19, 2001

Examiner: Unknown

For: METHOD FOR MEASURING COMA ABERRATION IN OPTICAL SYSTEM

Assistant Commissioner of Patents  
Washington, D.C. 20231

**SUBMISSION OF CORRECTED FORMAL DRAWINGS**

Sir:

Submitted herewith are corrected formal drawings for Figures 1-13(b) for the above-identified patent application.

Approval and acknowledgment of receipt are respectfully requested.

Date: 5/17/02

Respectfully submitted,

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